

Sheet 1 of 1

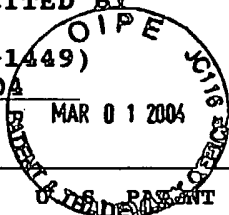
Atty. Docket No.  
4616/CON of 4194Serial No.:  
10/725,860

**LIST OF REFERENCES CITED BY  
APPLICANT**  
(REVISED FORM PTO-1449)  
DATED: February 25, 2004

Applicant: Hirokazu KUGAI et al.

U.S. Filing Date:  
December 1, 2003

Art Unit:



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EP	AR	US Patent Application Publication No. US 2002/0028383 A1, published on March 7, 2002, Kugai et al., Title: Thin Alkali Metal Film Member and Method of Producing the Same; Cover page, 1 sheet of drawings, and pages 1 to 6
EP	AS	US Patent Application Publication No. US 2003/0180608A1, published on September 25, 2003, Mori et al., Title: Lithium Secondary Cell and Method for Manufacture Thereof; cover page, 2 sheets of drawings, and pages 1 to 3.

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Sheet 1 of 1  
**SECOND**  
**LIST OF REFERENCES CITED BY**  
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 (REVISED FORM PTO-1449)  
 DATED: May 20, 2004

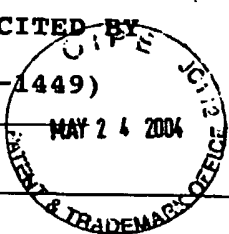
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 1745



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